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REPLY UNDER 37 CFR 1.116 EXPEDITED PROCEDURE TECHNOLOGY CENTER 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.

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Conf. No.

4826

In Re Application of: MacDonald

Art Unit:

2822

Filed:

08/05/2004

Dkt. #: FIS920040163US1 (IBMF-0064)

Cust. No.:

45094

Examiner:

Duong, Khanh B.

Title: METHOD OF FORMING A POLISHING INHIBITING LAYER USING A

SLURRY HAVING AN ADDITIVE

Mail Stop AF **Commissioner for Patents** P.O. Box 1450 Alexandria, VA 22313-1450

AFTER FINAL AMENDMENT

Sir:

I. **INTRODUCTORY COMMENTS**

In response to the Final Office Action of March 21, 2007, please reconsider the abovereferenced patent application in light of the following remarks:

The Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 9 of this paper.